



Max-Planck Institut für Eisenforschung GmbH

Interface Chemistry and Surface Engineering Department

Atomistic Modeling Group (AMG)

IMPRS-SurMat



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# ***FEM simulation of the scanning electrochemical potential microscopy (SECPM)***

Fayçal. R. Hamou

P.U. Biedermann, M. Rohwerder, A.T. Blumeneau



## Electrochemical Atomic Force Microscope (ECAFM)

nanometer-resolution AFM imaging of electrode surfaces in solution

## Electrochemical Scanning Tunneling Microscope (ECSTM)

STM imaging of electrode surfaces in solution under electrochemical control.

# Electrochemical Scanning Probe Microscope Systems ESPM

## Scanning Electrochemical Potential Microscope (SECPM)

## Scanning Electrochemical Microscope (SECM)

Imaging the surface using the Faradaic current from electrolysis of solution species



## Scanning Electrochemical Potential Microscopy (SECPM)

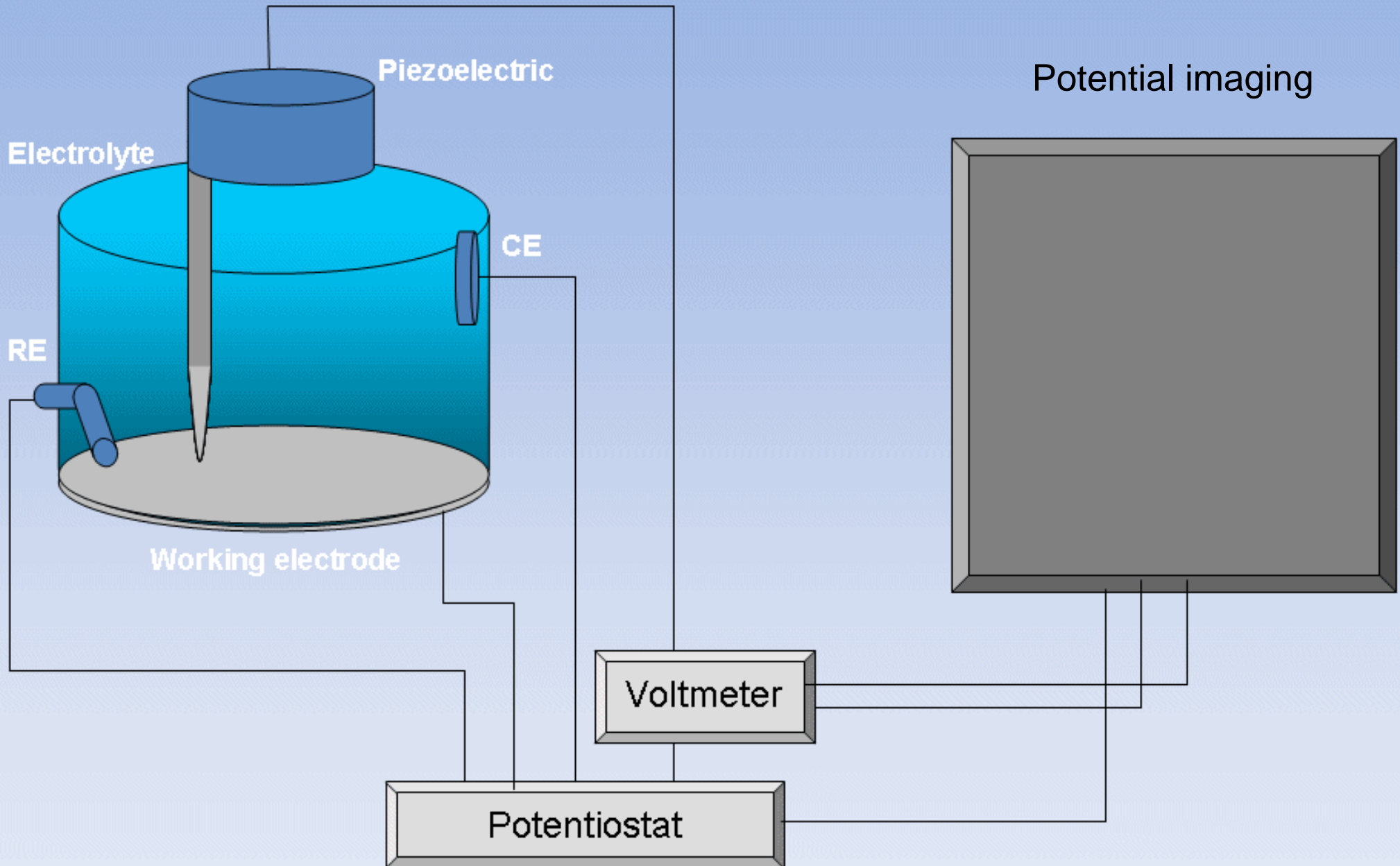


- *in-situ* imaging or potential mapping of the electrode surface with nanometer-scale resolution
- Measure the profile of Electrochemical Potential at the metal/electrolyte interface

Applications: electroplating, corrosion, and battery research and development.

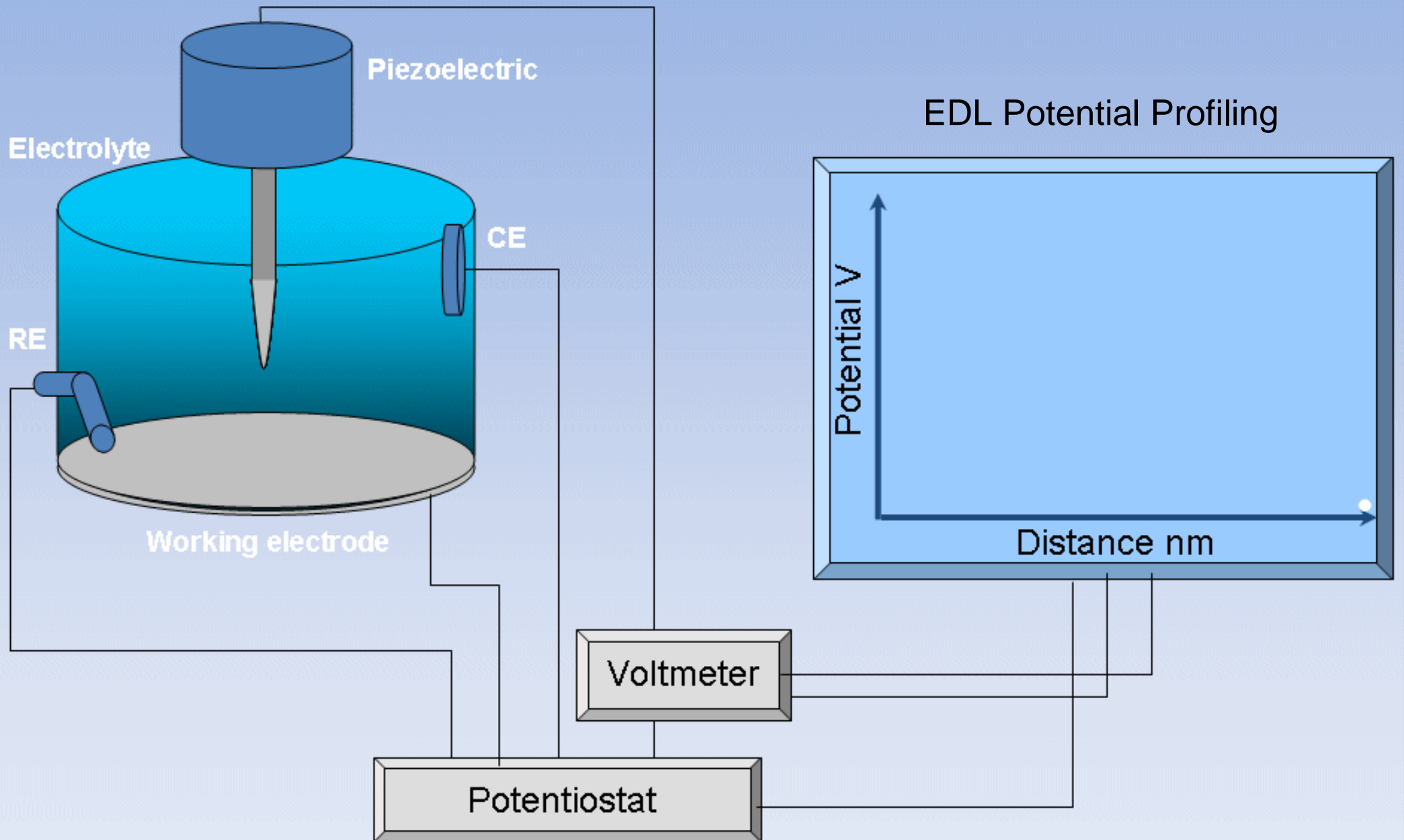


1. Constant Potential Mode
2. Constant Height Mode





# Spectroscopic Mode : Scanning in Z direction





## Potential Profiling:

SECPM measurement

- Low concentration
- Polar liquids
- Totally Inert metallic probe

Interpretation of the  
SECPM measurement

Theoretical model : Gouy-Chapmann-Stern

Fitting the results

Estimation of the parameters:

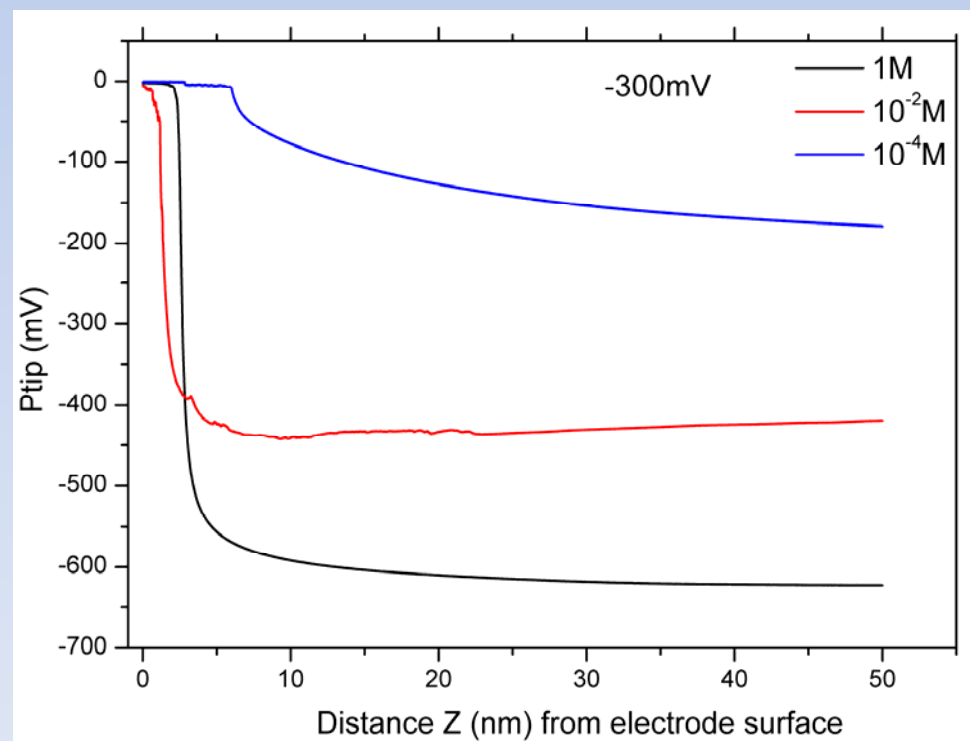
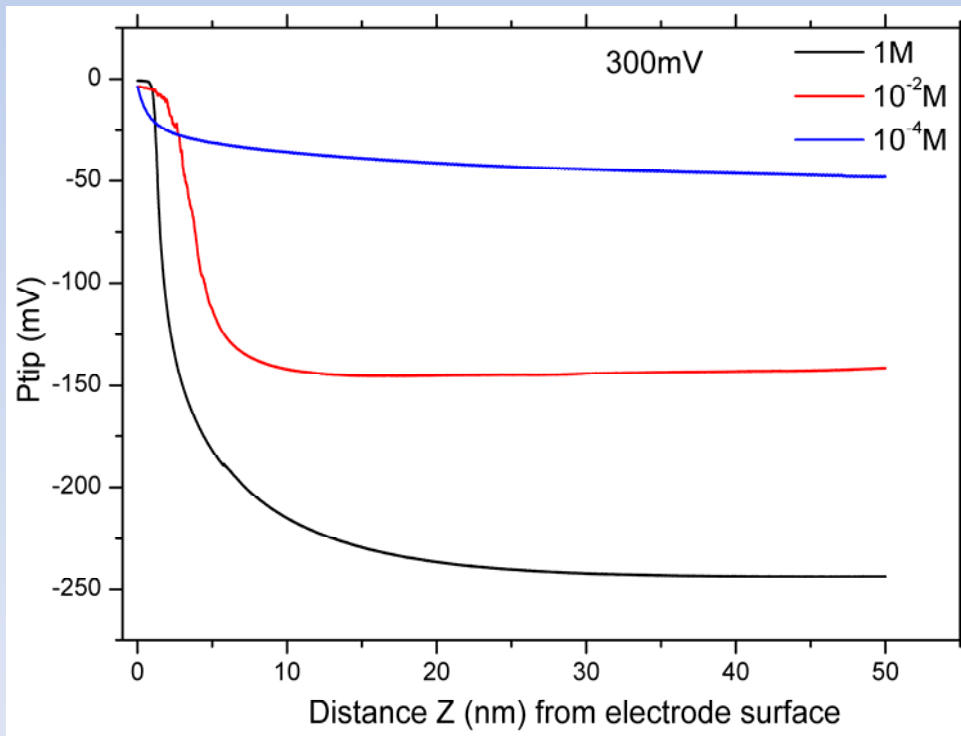
- Debye length
- Concentration profile at the interface.



## Recent experimental results

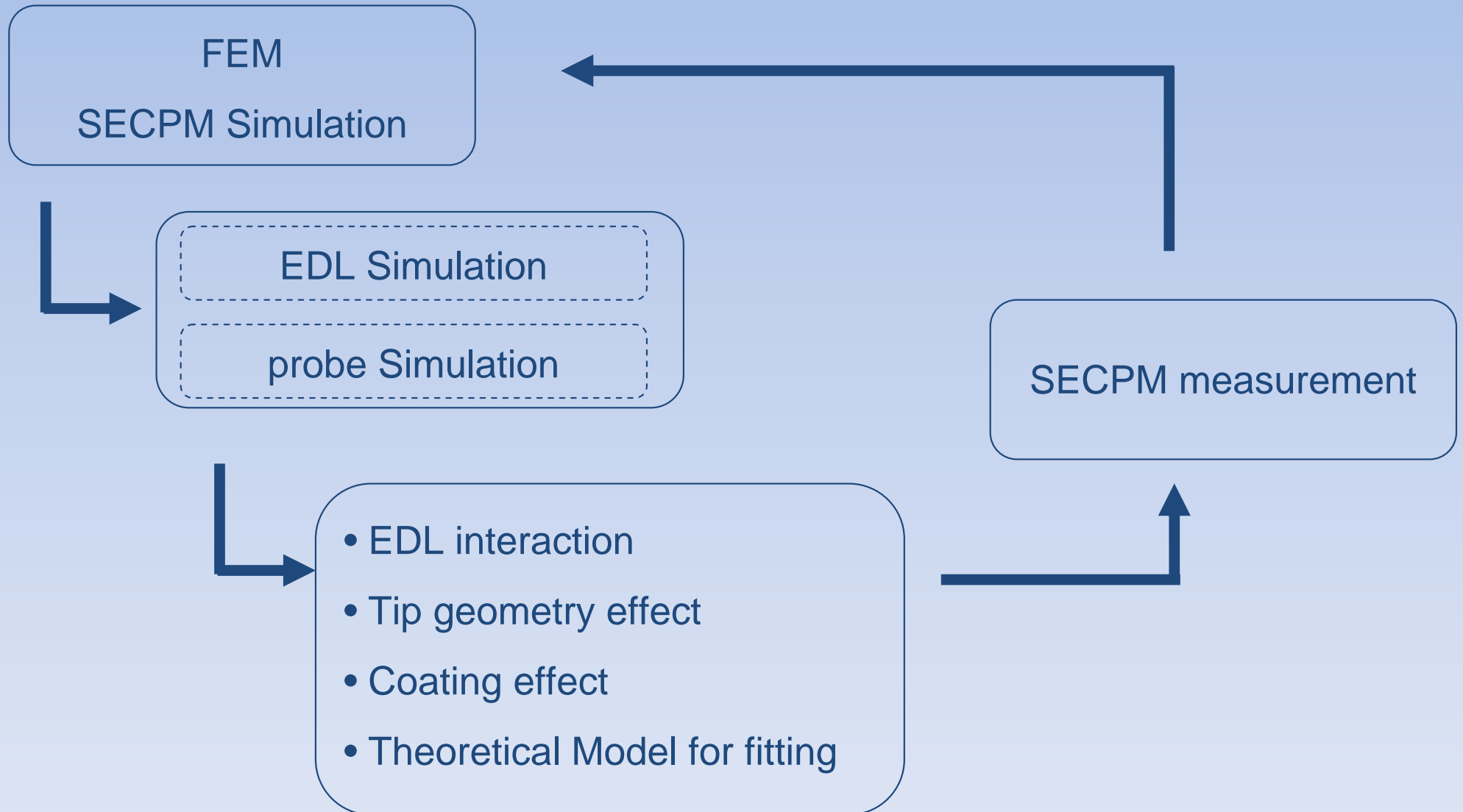
C. Hurth, C. Li, and Allen J. Bard, *J. Phys. Chem. C* **2007**, *111*, 4620-4627

- The Gouy-Chapman-Stern failed to describe the experiment results
- Non-Boltzmannian distribution of the ions
- The tip perturbs the electric double layer (EDL interaction)
- Theoretical approach is needed to interpret the SECPM measurement





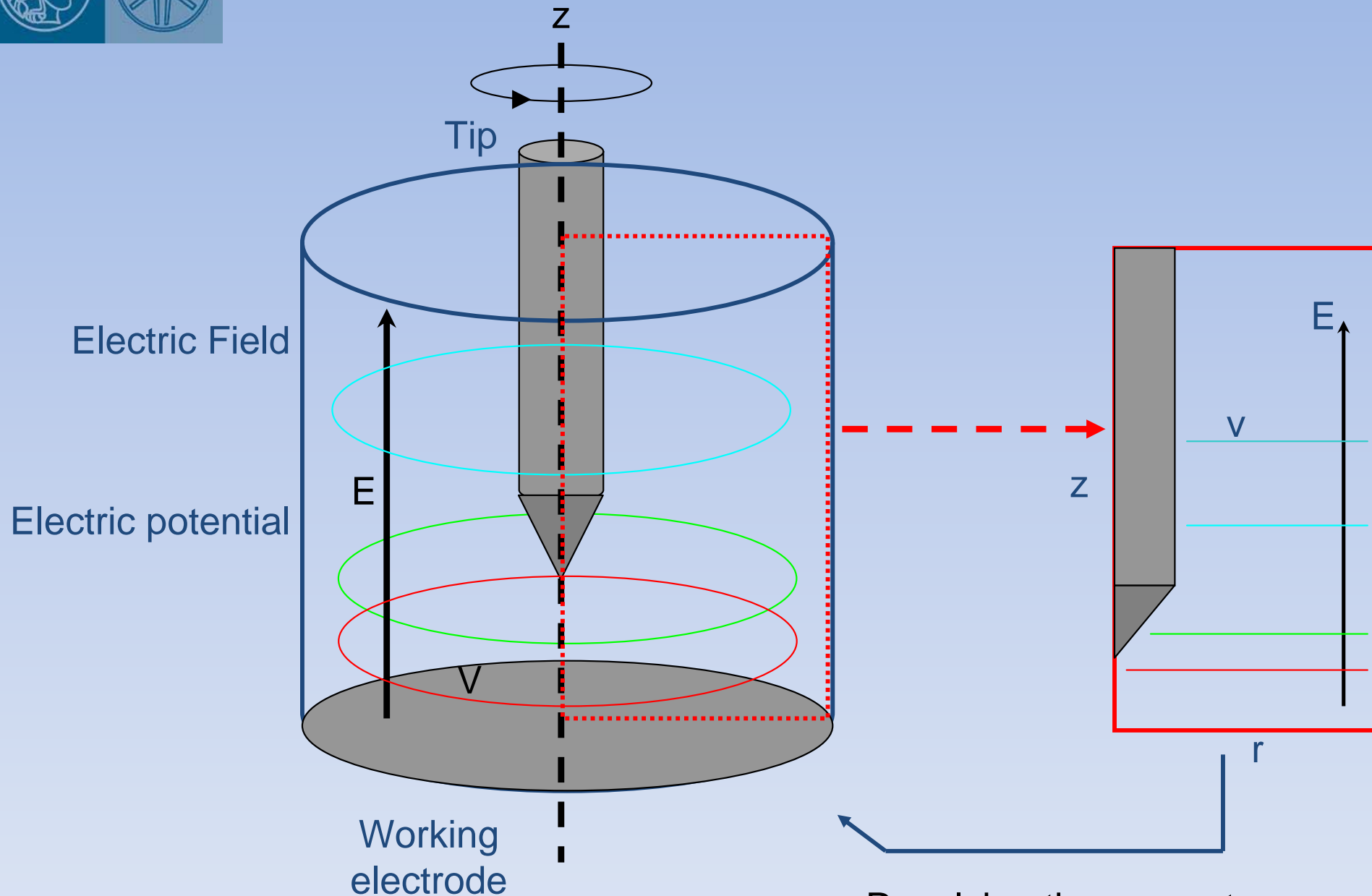
# Motivation







# Axial symmetric Model



The full 3D model

Revolving the geometry

Extrusion of the solution



# Nernst-Planck Equation in the steady state

Symmetric electrolyte 1:1

$$-D_1 \nabla^2 C_1 - D_1 \frac{zF}{RT} \nabla(C_1 \nabla V) = 0$$

$$-D_2 \nabla^2 C_2 - D_2 \frac{zF}{RT} \nabla(C_2 \nabla V) = 0$$

$$-\nabla(\epsilon_0 \epsilon \nabla V) = \rho = \sum N C_i z_i q$$

EDL

SECPM

Solving the PD equations for  $C_1$   $C_2$   $V$  and  $V_t$

$$\epsilon_0 \epsilon \nabla V_t = \rho_t \text{ Gauss' equation}$$

$$Q = \int N z_1 q C_1(x, y) + N z_2 q C_2(x, y)$$

Probe

Finite element method

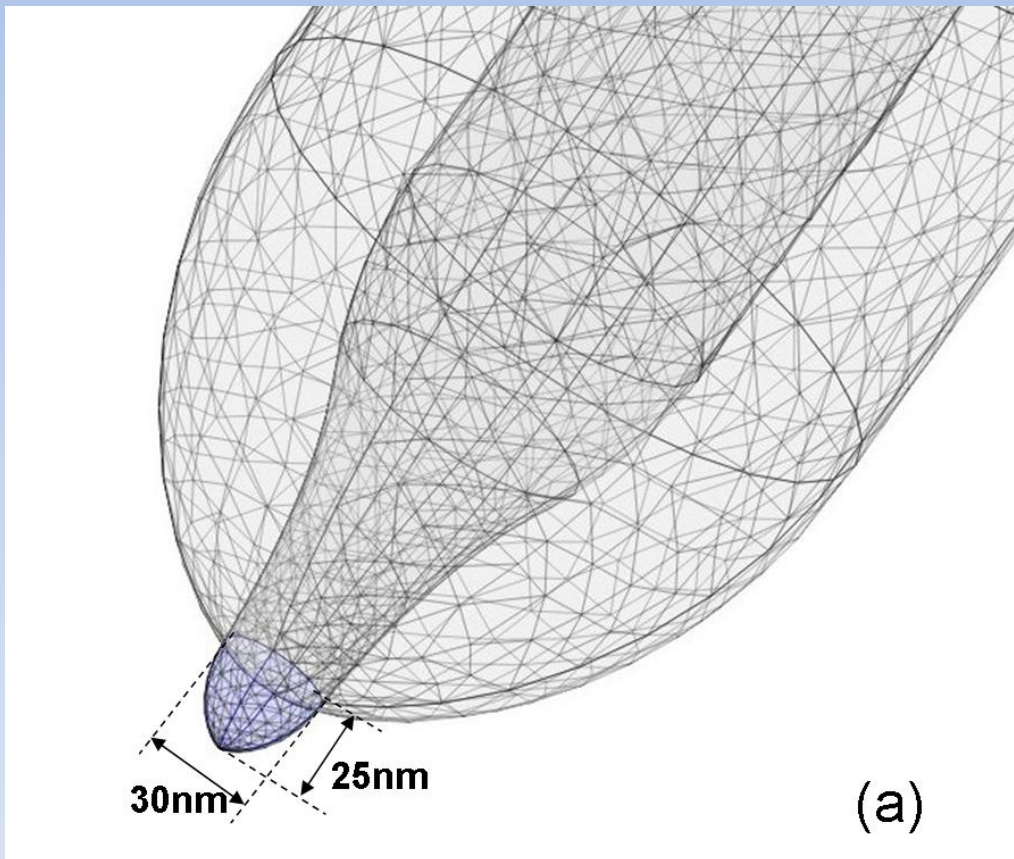
Multiphysics Modelling

Surrounding the metallic tip

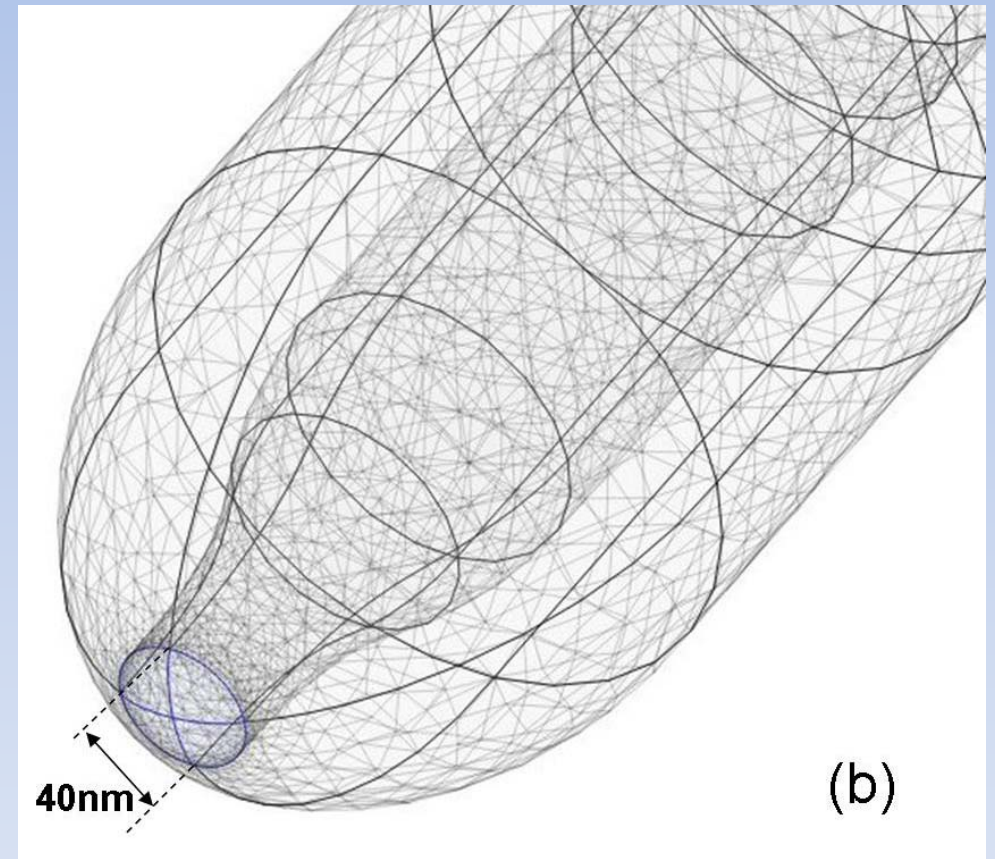


# Tip geometry effect

## Protruding tip



## Non-Protruding tip

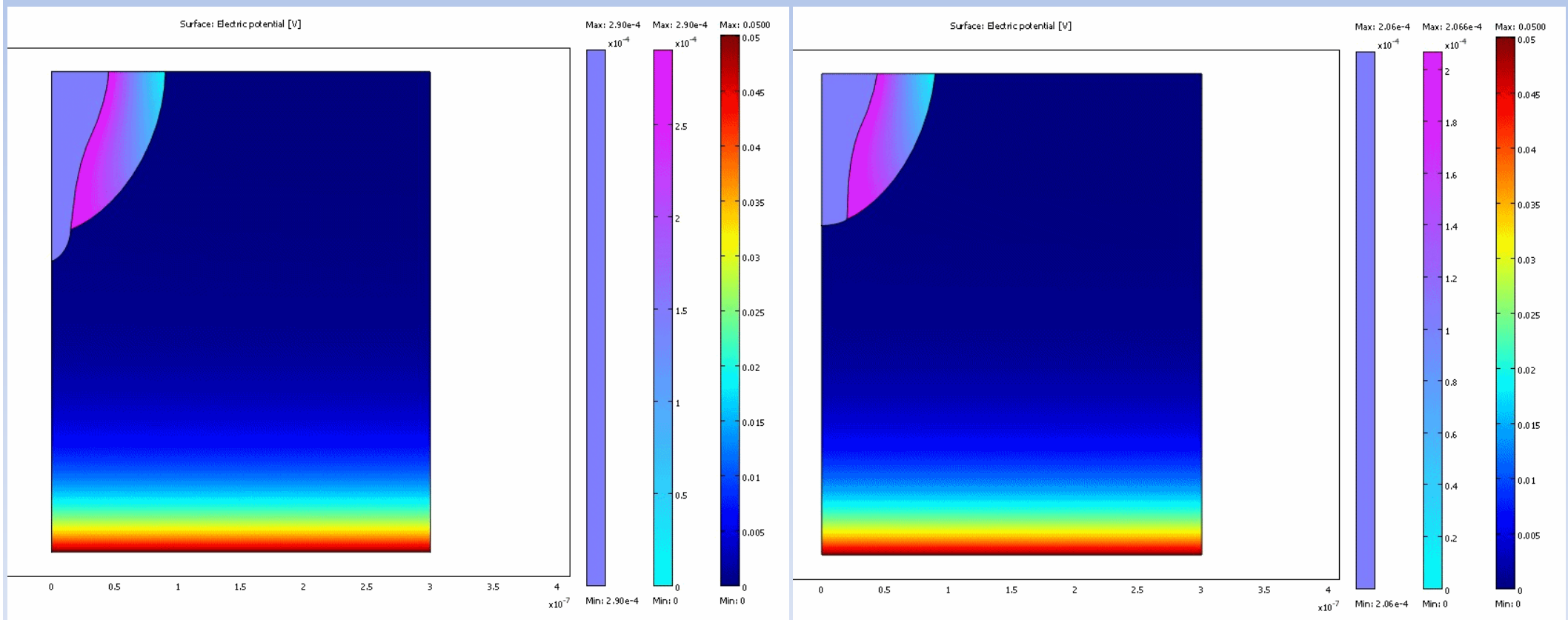




# Tip geometry effect: Electric potential distribution

## Protruding tip

## Non-Protruding tip

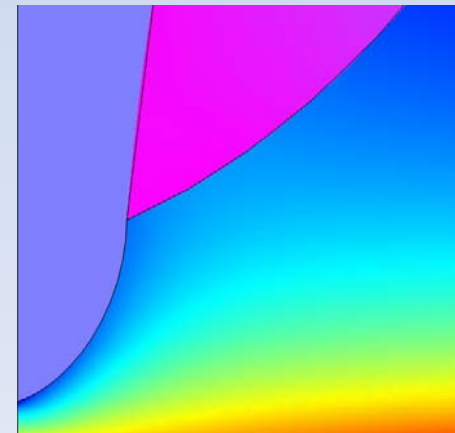
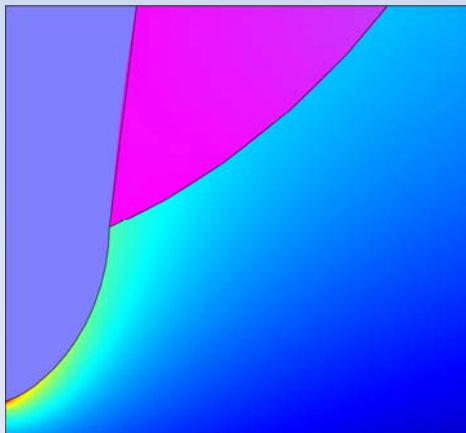
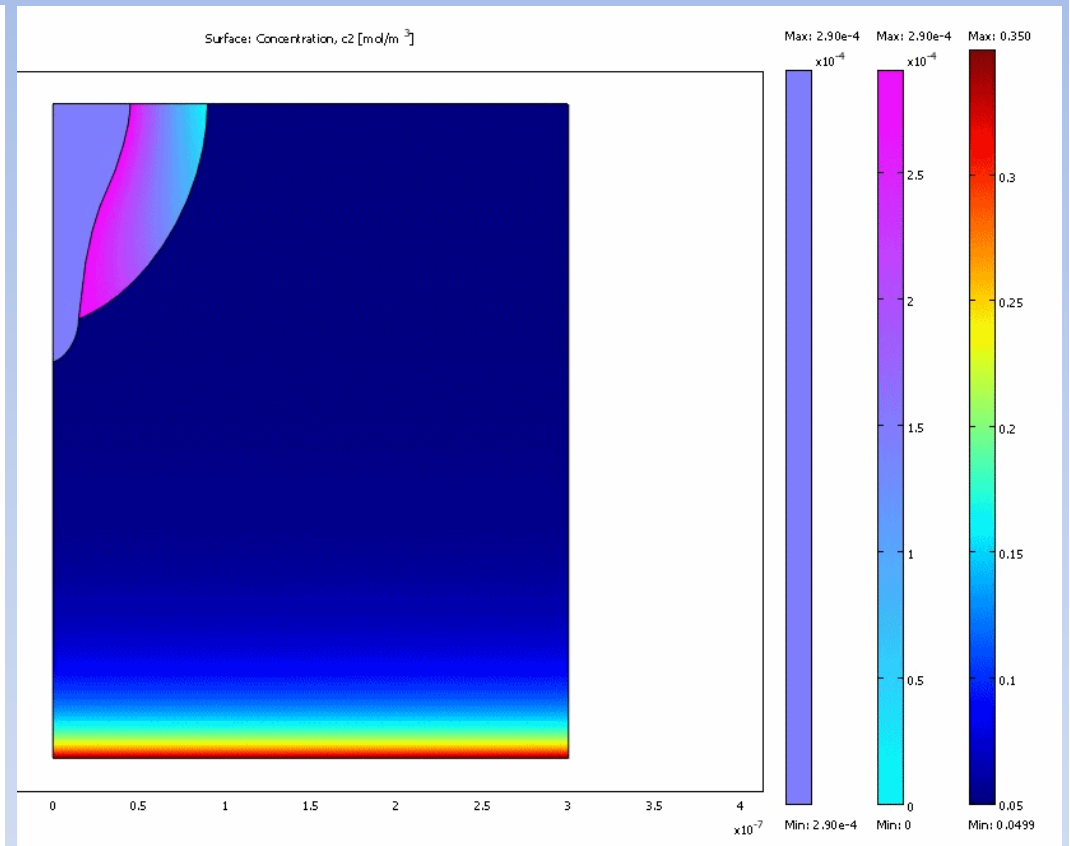
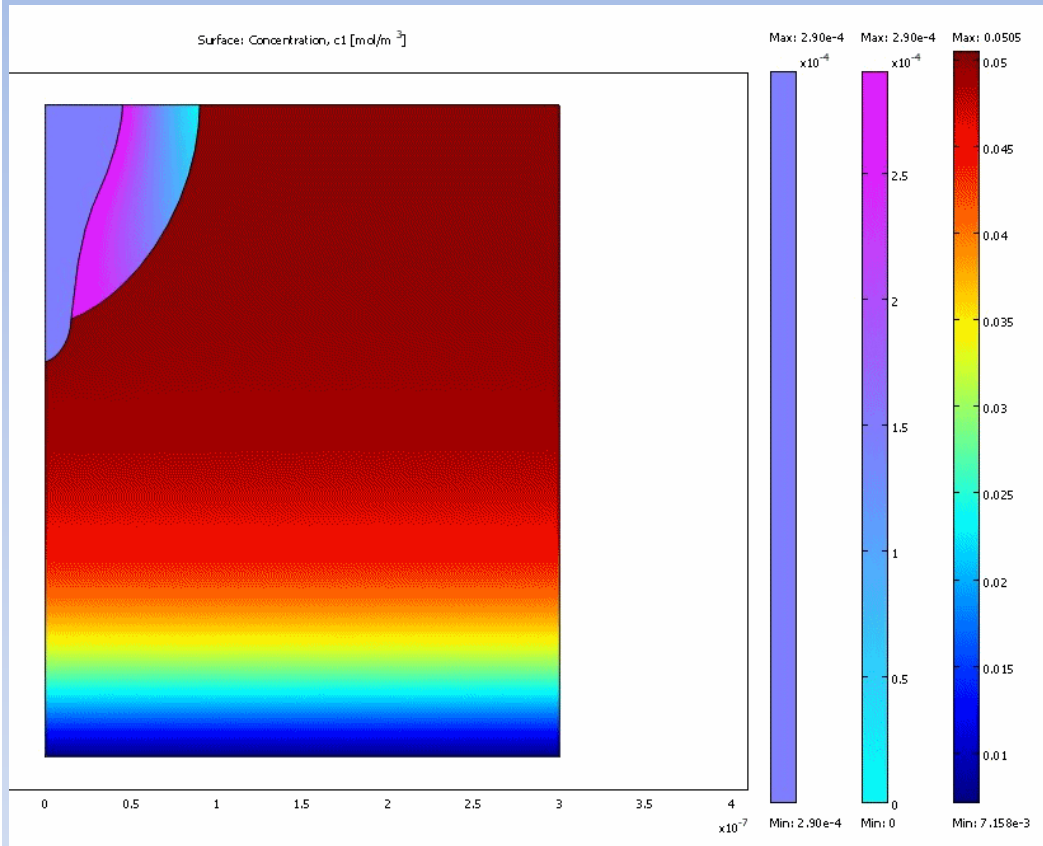




# Tip geometry effect: Ions distribution

## Cation

## Anion



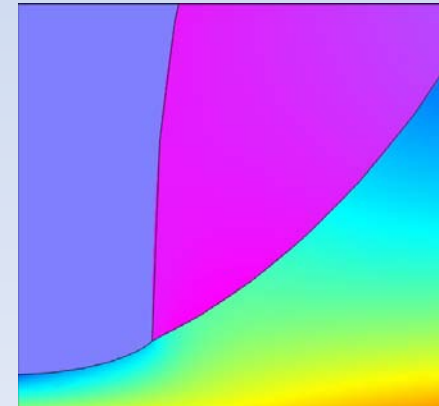
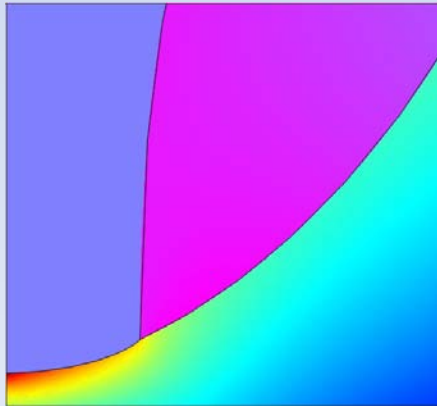
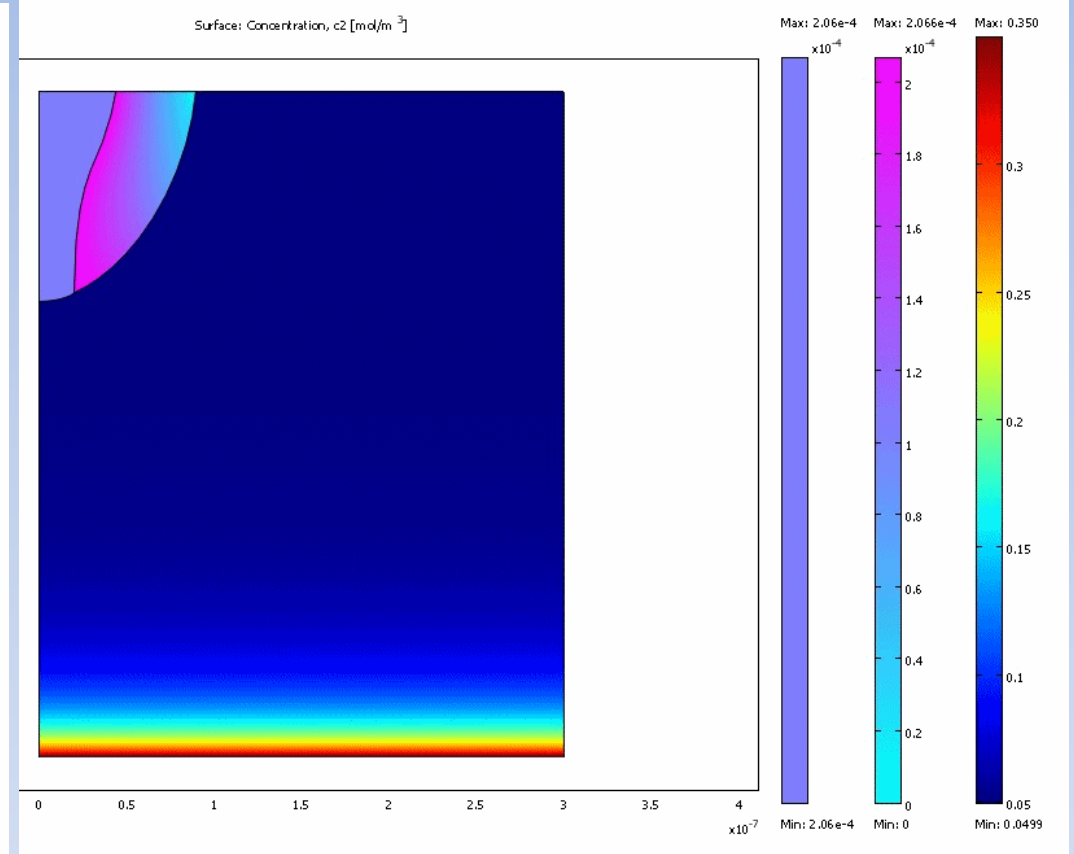
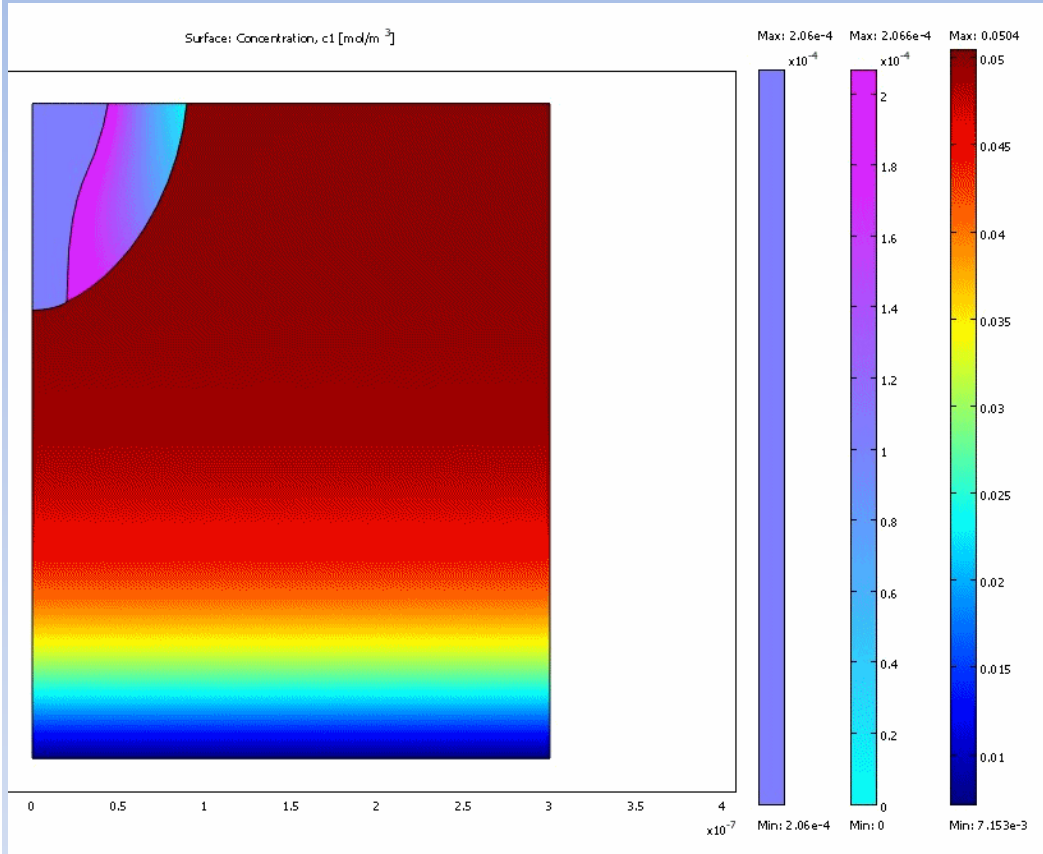




# Tip geometry effect: Ions distribution

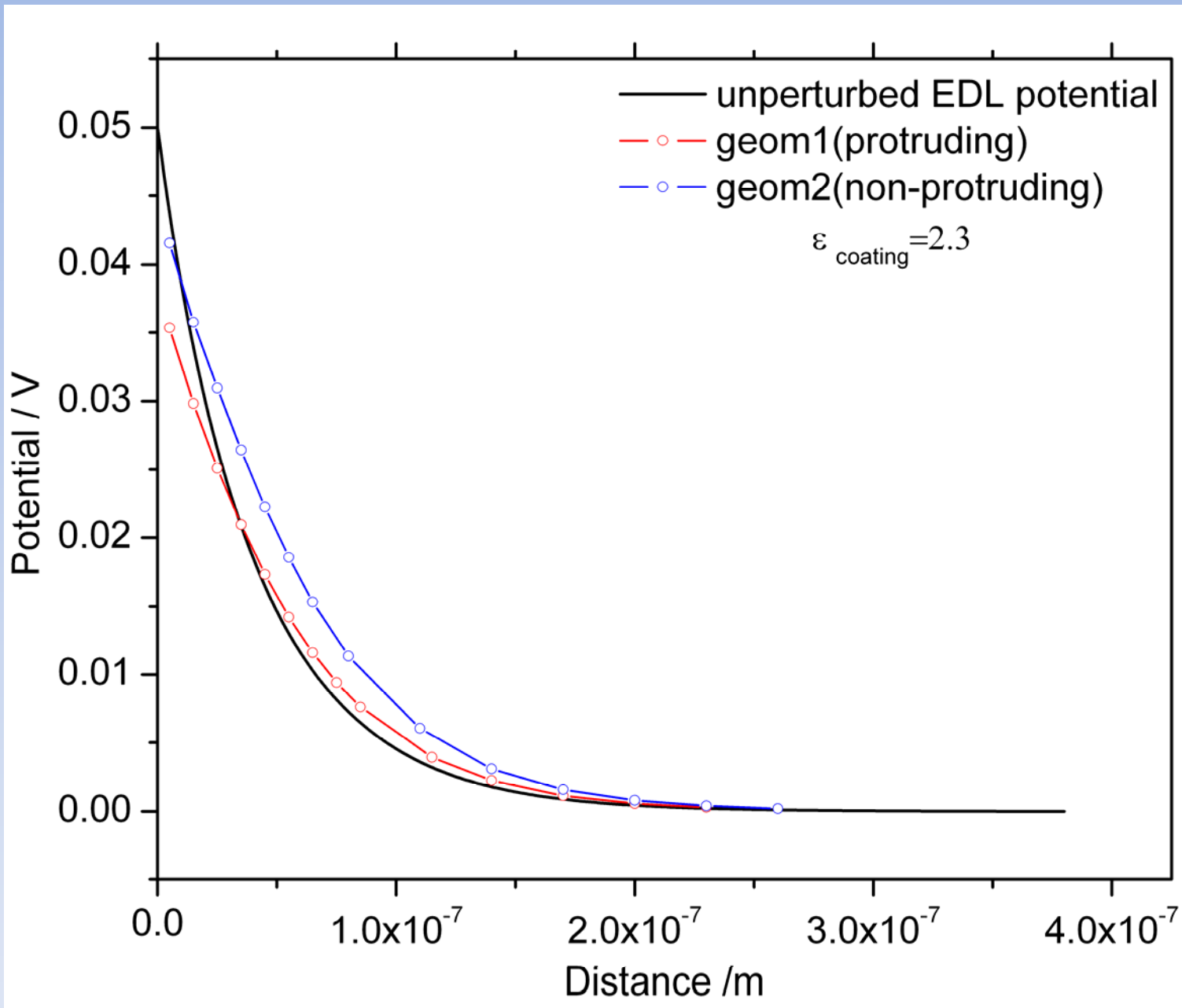
## Cation

## Anion



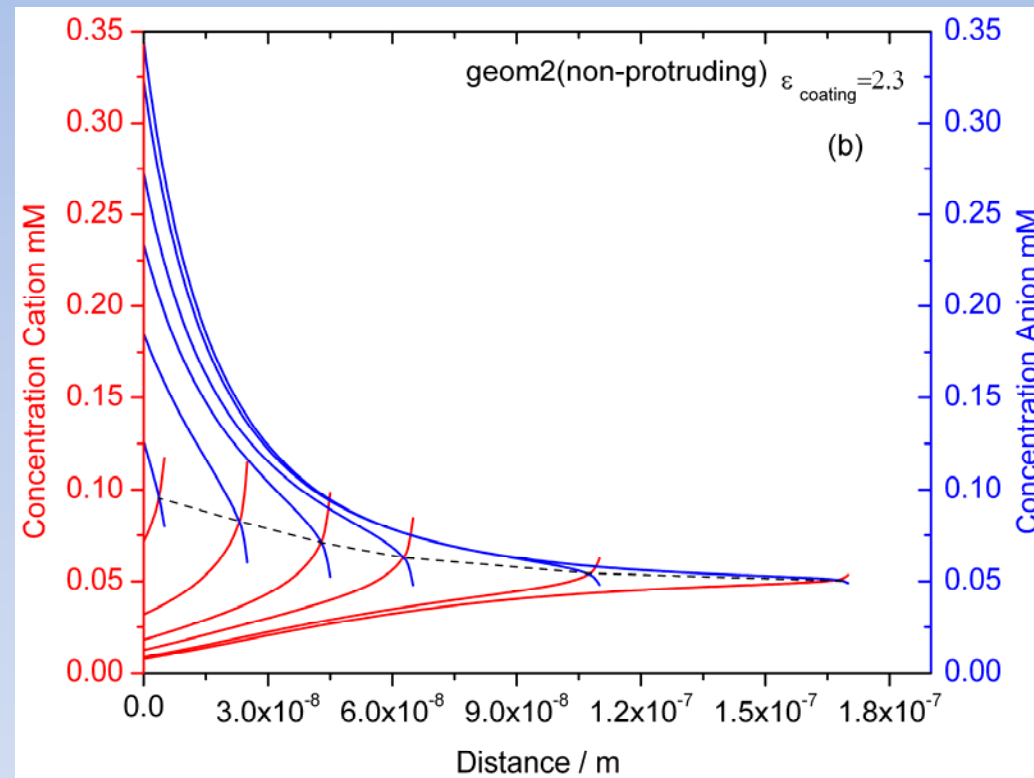
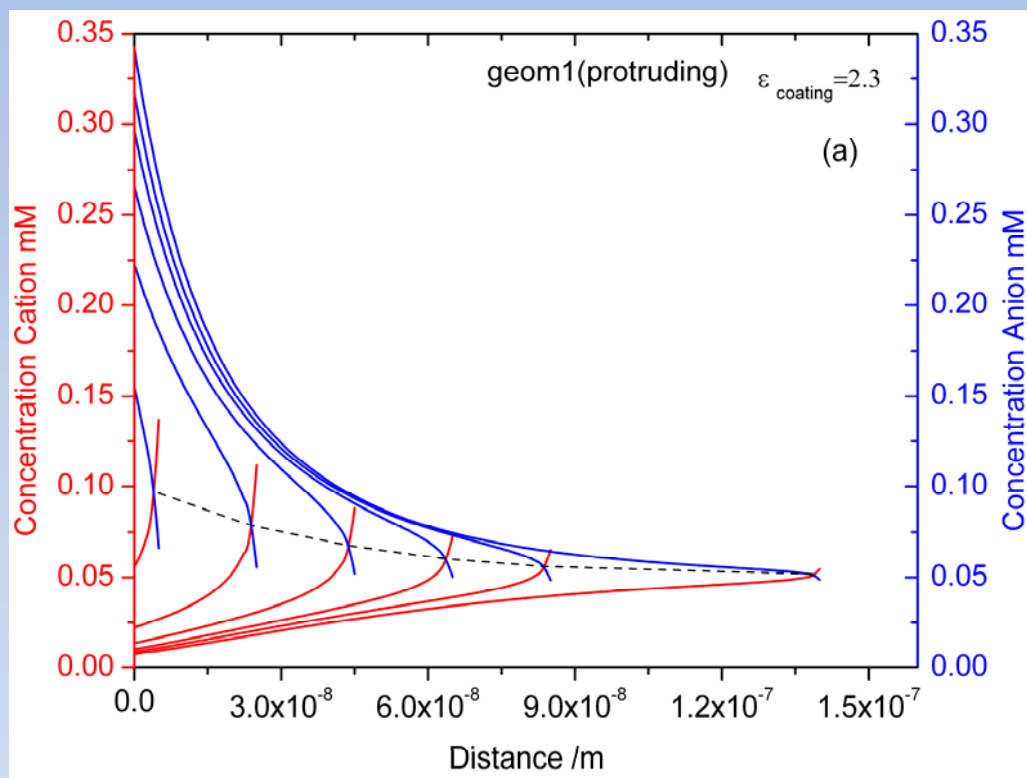


# Tip geometry effect: electric potential





# Tip geometry effect: ions distribution



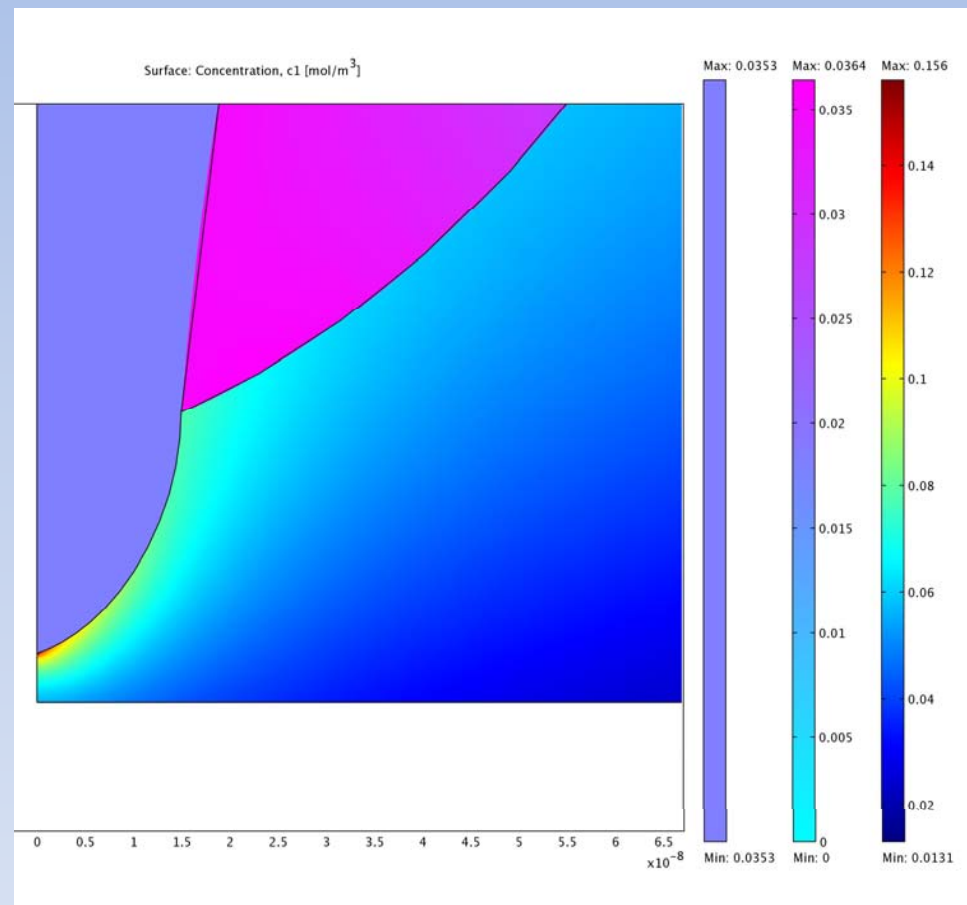
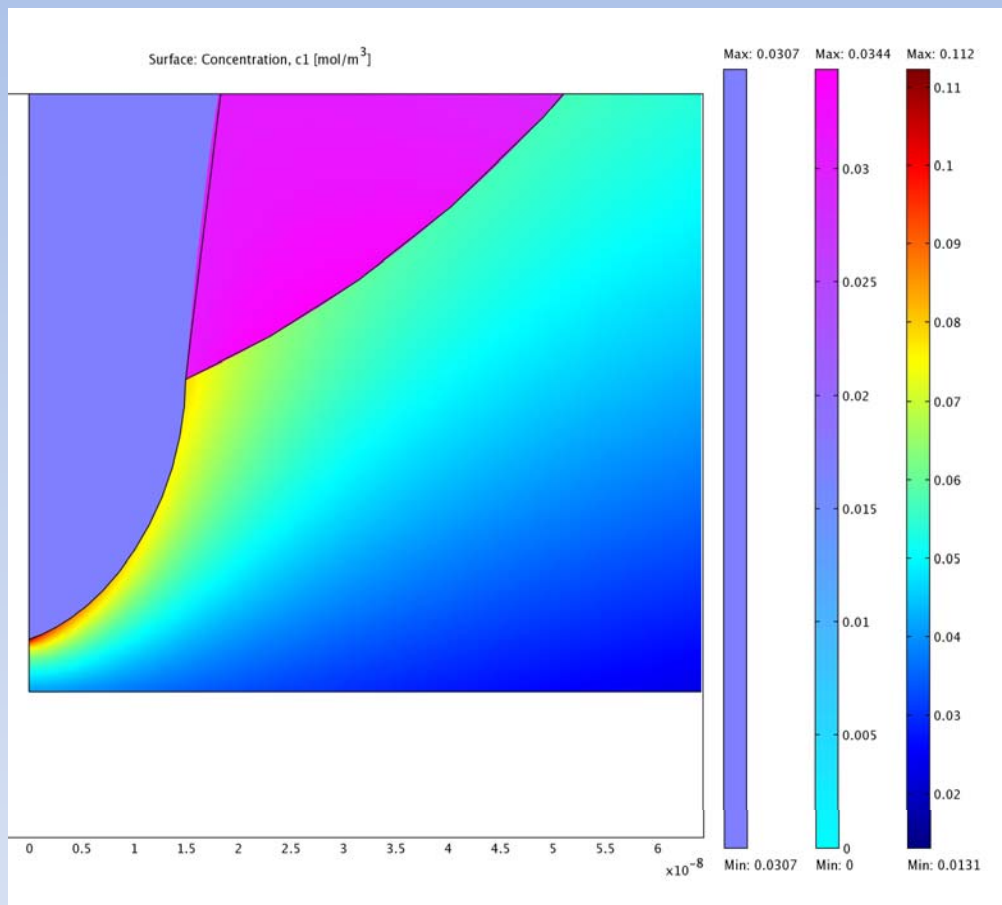




## Cation distribution

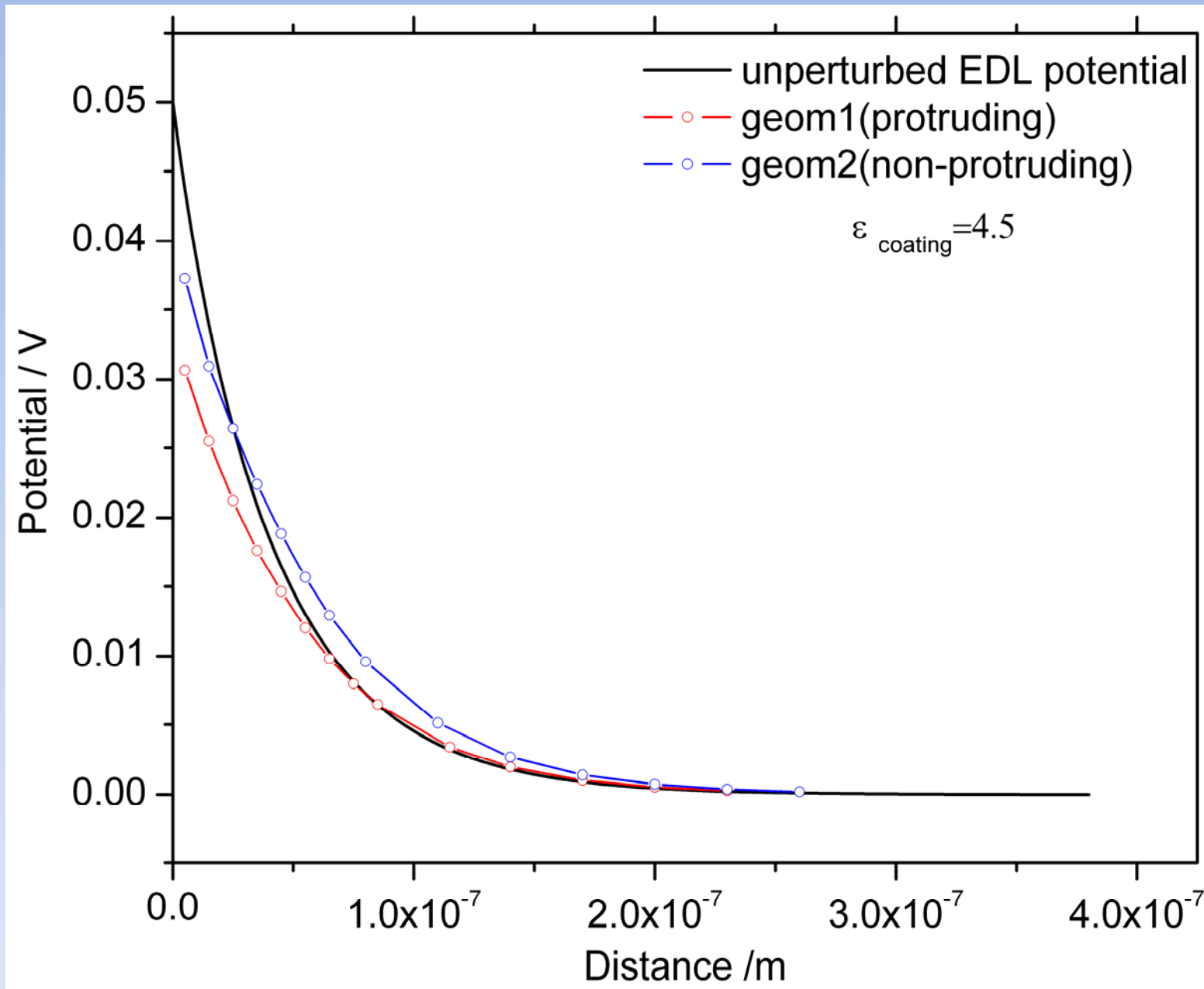
$\epsilon = 4.5$

$\epsilon = 2.3$



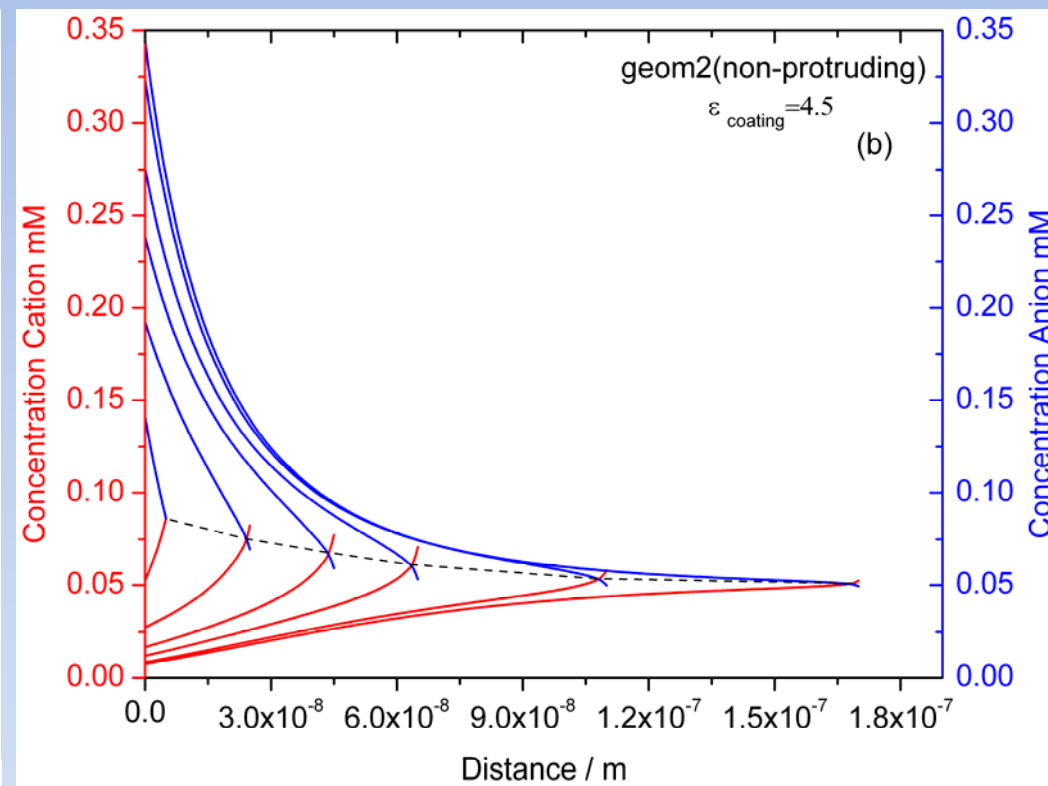
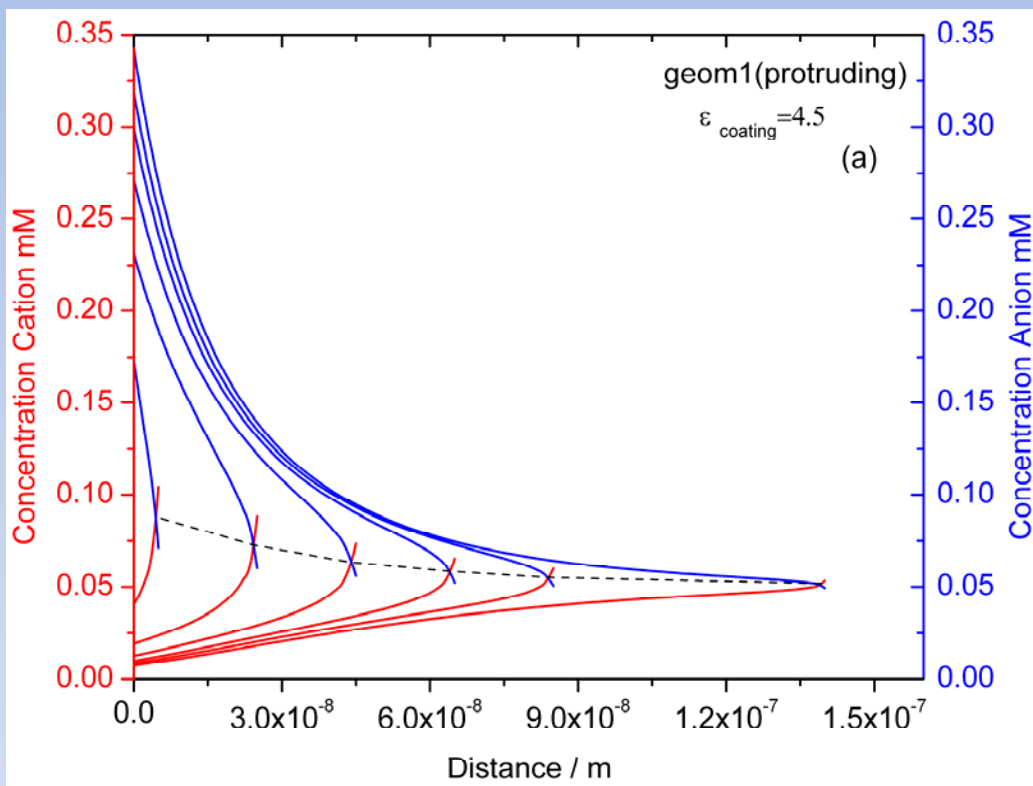


# Coating effect: electric potential





# Coating effect: ions distribution





## Outlook: Ion size effect, steric effect

SECPM experiment: applied electric potential >200 mV

Steric effect

The Gouy-Chapmann-Stern Model not valid for SECPM fitting or simulation

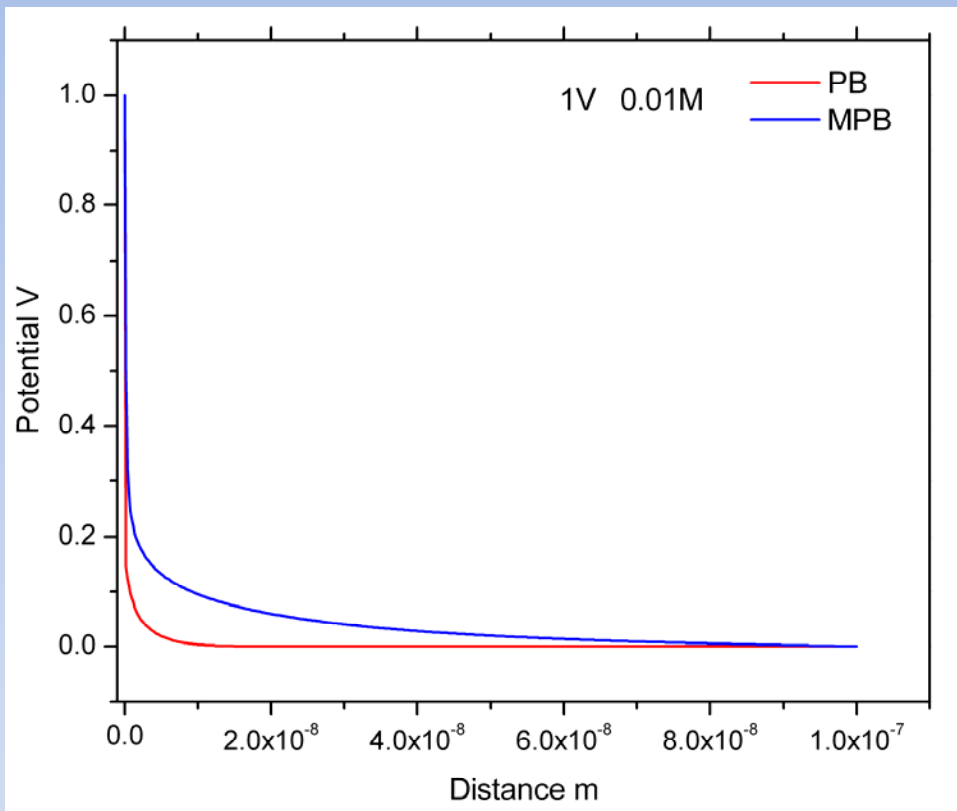
Modified Poisson Boltzmann

$$\nabla^2 V = \frac{NzqC_b}{\epsilon\epsilon_0} \frac{2 \sinh\left(\frac{zqV}{kT}\right)}{1 + 2\nu \sinh^2\left(\frac{zqV}{kT}\right)}$$

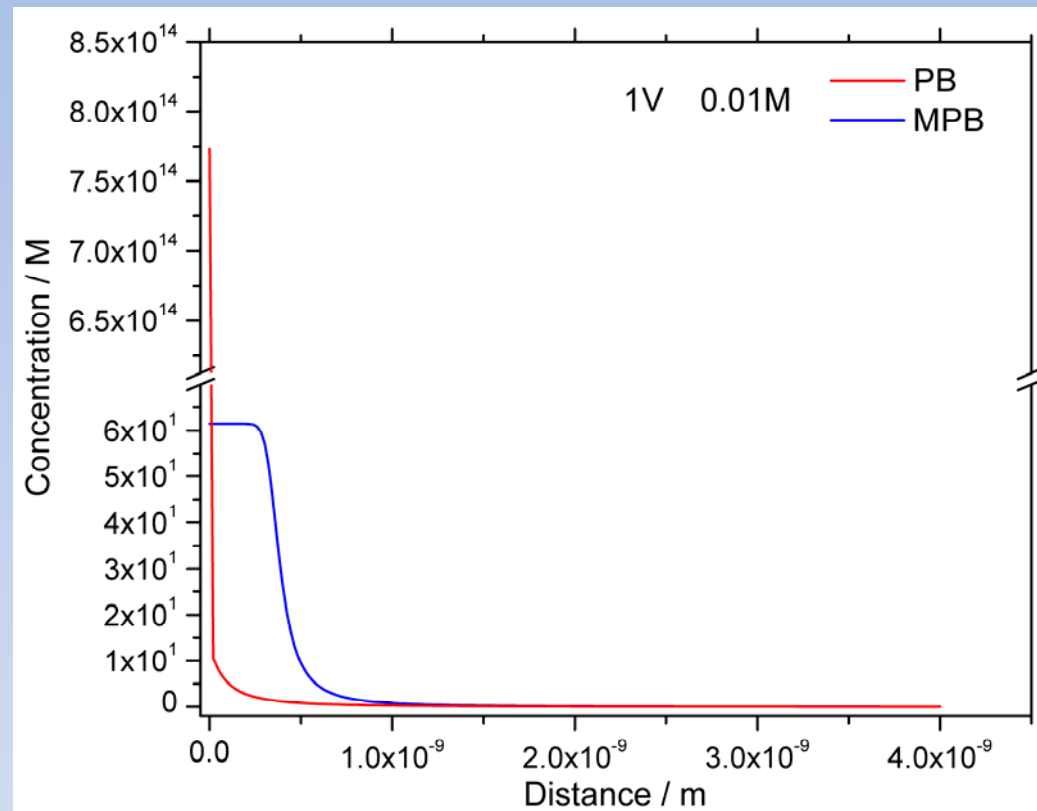


# Steric effect

## Potential



## Cation concentration



Near future: SECPM Simulation with the modified Poisson-Boltzmann Model



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- Dr. Andreas Erbe form MPIE
- YOU for listening